

L-Number	Hits	Search Text	DB	Time stamp
3	238	(((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (hydrogen "H.sub.2")) ((((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (oxygen "O.sub.2")) ((((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (nitrogen "N.sub.2")) and (TFT (thin near3 film near3 transistor))	USPAT; US-PGPUB	2004/06/16 17:33
5	53	((laser same ((natural near3 oxide) native))) and (TFT (thin near3 film near3 transistor))	USPAT; US-PGPUB	2004/06/16 13:26
4	885	(laser same ((natural near3 oxide) native))	USPAT; US-PGPUB	2004/06/16 17:11
6	126	(laser same ((natural near3 oxide) native))	EPO; JPO; DERWENT; IBM_TDB	2004/06/16 17:11
7	183	(laser and ((natural near3 oxide) native))	EPO; JPO; DERWENT; IBM_TDB	2004/06/16 17:11
8	183	((laser and ((natural near3 oxide) native))) ((laser same ((natural near3 oxide) native)))	EPO; JPO; DERWENT; IBM_TDB	2004/06/16 17:12
9	9	((laser and ((natural near3 oxide) native))) ((laser same ((natural near3 oxide) native))) and (TFT (thin near3 film near3 transistor))	EPO; JPO; DERWENT; IBM_TDB	2004/06/16 17:12
10	0	(((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (hydrogen "H.sub.2")) ((((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (oxygen "O.sub.2")) ((((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (nitrogen "N.sub.2")) and (TFT (thin near3 film near3 transistor))	EPO; JPO; DERWENT; IBM_TDB	2004/06/16 17:33
-	425153	(silicon (amorphous near3 silicon) a-silicon a-si)	USPAT; US-PGPUB	2004/06/03 21:33
-	219940	((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)	USPAT; US-PGPUB	2004/06/03 21:35
-	6996	((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)	USPAT; US-PGPUB	2004/06/03 21:35

-	1886	(((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser	USPAT; US-PGPUB	2004/06/03 21:35
-	1751	(((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)	USPAT; US-PGPUB	2004/06/03 21:19
-	1393	(((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10	USPAT; US-PGPUB	2004/06/03 21:35
-	572	(((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride))	USPAT; US-PGPUB	2004/06/03 21:35
-	787	(((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))	USPAT; US-PGPUB	2004/06/03 21:25
-	620	(((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (hydrogen "H.sub.2")	USPAT; US-PGPUB	2004/06/03 21:36
-	706	(((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (oxygen "O.sub.2")	USPAT; US-PGPUB	2004/06/03 21:36
-	598	(((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (nitrogen "N.sub.2")	USPAT; US-PGPUB	2004/06/03 21:36
-	768	(((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (hydrogen "H.sub.2")) ((((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (oxygen "O.sub.2")) ((((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (nitrogen "N.sub.2"))	USPAT; US-PGPUB	2004/06/03 21:27

-	235	(((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (hydrogen "H.sub.2")) ((((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (oxygen "O.sub.2")) ((((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (nitrogen "N.sub.2")) and (TFT (thin near3 film near3 transistor))	USPAT; US-PGPUB	2004/06/16 13:14
-	425229	(silicon (amorphous near3 silicon) a-silicon a-si alpha-silicon alpha-Si)	USPAT; US-PGPUB	2004/06/03 21:34
-	219971	((silicon (amorphous near3 silicon) a-silicon a-si alpha-silicon alpha-Si)) and (air ambient atmosphere)	USPAT; US-PGPUB	2004/06/03 21:35
-	6996	((silicon (amorphous near3 silicon) a-silicon a-si alpha-silicon alpha-Si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)	USPAT; US-PGPUB	2004/06/03 21:35
-	1886	((silicon (amorphous near3 silicon) a-silicon a-si alpha-silicon alpha-Si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser	USPAT; US-PGPUB	2004/06/03 21:35
-	1460	((silicon (amorphous near3 silicon) a-silicon a-si alpha-silicon alpha-Si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and crystal\$10	USPAT; US-PGPUB	2004/06/03 21:35
-	587	((silicon (amorphous near3 silicon) a-silicon a-si alpha-silicon alpha-Si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and crystal\$10) and (HF (hydrogen near3 fluoride))	USPAT; US-PGPUB	2004/06/03 21:36
-	446	((silicon (amorphous near3 silicon) a-silicon a-si alpha-silicon alpha-Si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and crystal\$10) and (HF (hydrogen near3 fluoride))) and (hydrogen "H.sub.2")	USPAT; US-PGPUB	2004/06/03 21:36
-	524	((silicon (amorphous near3 silicon) a-silicon a-si alpha-silicon alpha-Si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and crystal\$10) and (HF (hydrogen near3 fluoride))) and (oxygen "O.sub.2")	USPAT; US-PGPUB	2004/06/03 21:36
-	381	((silicon (amorphous near3 silicon) a-silicon a-si alpha-silicon alpha-Si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and crystal\$10) and (HF (hydrogen near3 fluoride))) and (oxygen "O.sub.2")) and (nitrogen "N.sub.2")	USPAT; US-PGPUB	2004/06/03 21:37

-	564	<pre> (((((((silicon (amorphous near3 silicon) a-silicon a-si alpha-silicon alpha-Si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and crystal\$10) and (HF (hydrogen near3 fluoride))) and (hydrogen "H.sub.2")) (((((((silicon (amorphous near3 silicon) a-silicon a-si alpha-silicon alpha-Si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and crystal\$10) and (HF (hydrogen near3 fluoride))) and (oxygen "O.sub.2")) (((((((silicon (amorphous near3 silicon) a-silicon a-si alpha-silicon alpha-Si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and crystal\$10) and (HF (hydrogen near3 fluoride))) and (oxygen "O.sub.2")) and (nitrogen "N.sub.2")) </pre>	USPAT; US-PGPUB	2004/06/03 21:37
-	780	<pre> (((((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (hydrogen "H.sub.2")) (((((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (oxygen "O.sub.2")) (((((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (nitrogen "N.sub.2")) (((((((silicon (amorphous near3 silicon) a-silicon a-si alpha-silicon alpha-Si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and crystal\$10) and (HF (hydrogen near3 fluoride))) and (hydrogen "H.sub.2")) (((((((silicon (amorphous near3 silicon) a-silicon a-si alpha-silicon alpha-Si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and crystal\$10) and (HF (hydrogen near3 fluoride))) and (oxygen "O.sub.2")) (((((((silicon (amorphous near3 silicon) a-silicon a-si alpha-silicon alpha-Si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and crystal\$10) and (HF (hydrogen near3 fluoride))) and (oxygen "O.sub.2")) and (nitrogen "N.sub.2")) </pre>	USPAT; US-PGPUB	2004/06/03 21:38

-	235	((((((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (hydrogen "H.sub.2")) (((((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (oxygen "O.sub.2")) (((((((silicon (amorphous near3 silicon) a-silicon a-si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and (anneal\$3 heat\$3)) and crystal\$10) and (HF (hydrogen near3 fluoride) (hydrofluor\$3 near3 acid))) and (nitrogen "N.sub.2")) (((((((silicon (amorphous near3 silicon) a-silicon a-si alpha-silicon alpha-Si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and crystal\$10) and (HF (hydrogen near3 fluoride))) and (hydrogen "H.sub.2")) (((((((silicon (amorphous near3 silicon) a-silicon a-si alpha-silicon alpha-Si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and crystal\$10) and (HF (hydrogen near3 fluoride))) and (oxygen "O.sub.2")) (((((((silicon (amorphous near3 silicon) a-silicon a-si alpha-silicon alpha-Si)) and (air ambient atmosphere)) and ((native natural) near5 oxid\$6)) and laser) and crystal\$10) and (HF (hydrogen near3 fluoride))) and (oxygen "O.sub.2")) and (nitrogen "N.sub.2")))) and (TFT (thin near3 film near3 transistor))	USPAT; US-PGPUB	2004/06/03 21:38
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